

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L1	720	LDMOS\$2 or LD-MOS\$2 or (LD adj MOS\$3) or LDMOSFET\$1 or LD-MOSFET\$1 or (LD adj MOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:14			0
2	BRS	L2	51	lateral\$4 adj diffus\$5 adj metal adj oxide adj semiconductor\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:16			0
3	BRS	L3	60	lateral\$4 adj diffus\$5 adj (MOS\$3 or MOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:16			0
4	BRS	L4	479	LDDMOS\$2 or LDD-MOS\$2 or (LDD adj MOS\$3) or LDDMOSFET\$1 or LDD-MOSFET\$1 or (LDD adj MOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:17			0
5	BRS	L5	74	(lateral\$4 adj double adj diffus\$5 adj metal adj oxide adj semiconductor\$4) or (lateral\$4 adj double-diffus\$5 adj metal adj oxide adj semiconductor\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:19			0
6	BRS	L6	178	lateral\$4 adj double adj diffus\$5 adj (MOS\$3 or MOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:20			0
7	BRS	L7	249	lateral\$4 near\$7 (metal adj oxide adj semiconductor\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:21			0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Error
8	BRS	L8	2322	lateral\$4 near7 (MOS or MOSFET\$1 or NMOS or NMOSFET\$1 or PMOS or PMOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:27			0
9	BRS	L9	10	LDPMOS\$2 or LD-PMOS\$2 or (LD adj PMOS\$3) or LDPMOSFET\$1 or LD-PMOSFET\$1 or (LD adj PMOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:24			0
10	BRS	L10	5	LDNMOS\$2 or LD-NMOS\$2 or (LD adj NMOS\$3) or LDNMOSFET\$1 or LD-NMOSFET\$1 or (LD adj NMOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:25			0
11	BRS	L11	455	lateral\$4 near7 (DMOS or DMOSFET\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:26			0
12	BRS	L12	8141	lateral\$4 adj8 (MOS or MOSFET\$1 or NMOS or NMOSFET\$1 or PMOS or PMOSFET\$1 or FET\$1 or transistor\$1 or IGFET\$1 or (insulator\$5 adj gate adj field adj effect adj transistor\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:30			0
13	BRS	L13	9373	1 or 2 or 3 or 4 or 5 or 6 or 7 or 8 or 9 or 10 or 11 or 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:32			0

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14	BRS	L14	152308	(gate\$1 or electrode\$1) and source\$1 and drain\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:33			0
15	BRS	L15	140917	(field adj (oxide\$1 or isolat\$5)) or LOCOS\$2 or trench\$2 or STI\$1 or (shallow adj trench\$2 adj isolat\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:36			0
16	BRS	L16	1922	13 and 14 and 15	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:36			0
17	BRS	L17	15865	(amorphous or amorph\$9) near3 (region\$1 or area\$1 or part\$1 or portion\$1 or element\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 17:54			0
18	BRS	L18	39181	(amorphous or amorph\$9) near3 (layer\$1 or substrate\$1 or wafer\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:05			0
19	BRS	L19	30917	(amorphous or amorph\$9) near3 film\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:11			0
20	BRS	L20	67049	17 or 18 or 19	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:11			0

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	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
21	BRS	L21	204	16 and 20	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:12			0
22	BRS	L22	5147	implant\$8 adj (silicon or Si or "Si" or Ge or "Ge" or germanium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:13			0
23	BRS	L23	69	21 and 22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:25			0
24	BRS	L24	498	20 same 22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:47			0
25	BRS	L25	30	13 and 24	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:26			0
26	BRS	L26	330	20 with 22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:47			0
27	BRS	L27	22	26 and 13	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:50			0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
28	BRS	L28	23681	20 with (substrate or wafer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:51			0
29	BRS	L29	244	22 same 28	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:51			0
30	BRS	L30	16	13 and 29	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/03/15 18:52			0

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